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CONFIRMATION NO. 3943

Bib Data Sheet

SERIAL NUMBER 10/628,001	FILING OR 371(c) DATE 07/25/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. AMAT/7938/ETCH/SILICON/JB
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APPLICANTS

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 Lei Lian, Santa Clara, CA;

No

** CONTINUING DATA *****

No

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/10/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 11	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verifier and Acknowledged <i>Charles Steven</i> <i>Initials</i> Examiner's Signature <i>Allowance</i> Initials				

ADDRESS

44182

TITLE

Method for automatic determination of semiconductor plasma chamber matching and source of fault by comprehensive plasma monitoring

FILING FEE RECEIVED 1638	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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